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# Spontaneous charging affects the motion of sliding drops

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Water drops moving on surfaces are not only an everyday phenomenon seen on windows but also form an essential part of many industrial processes. Previous understanding is that drop motion is dictated by viscous dissipation and activated dynamics at the contact line. Here we demonstrate that these two effects cannot fully explain the complex paths of sliding or impacting drops. To accurately determine the forces experienced by moving drops, we imaged their trajectory when sliding down a tilted surface, and applied the relevant equations of motion. We found that drop motion on low-permittivity substrates is substantially influenced by electrostatic forces. Our findings confirm that electrostatics must be taken into consideration for the description of the motion of water, aqueous electrolytes and ethylene glycol on hydrophobic surfaces. Our results are relevant for improving the control of drop motion in many applications, including printing, microfluidics, water management and triboelectric nanogenerators.

ater drops moving on surfaces are a common phenomenon. The lateral adhesion of drops can be a nuisance; for example, nature developed sophisticated surface structures to keep feathers, fur or plant leaves dry. Science and technology have adopted these surface modifications to keep drops from sticking on textiles, in microfluidics, or to keep window screens and glasses clear in the rain<sup>1-4</sup>. In other applications, the resistance of sessile drops to sliding motion is essential, for example, in coating, painting, flotation and deposition of insecticides and herbicides<sup>5,6</sup>. Still, a full description of forces acting on moving drops remains elusive. Closing this gap of knowledge has become more imperative due to the recent endeavour to generate electricity from moving drops<sup>7–15</sup>. This direct form of harvesting hydrovoltaic energy without moving parts promises to expand the range of hydroelectricity generation to small-scale devices applicable in remote and off-grid areas, or as emergency generators. The efficiency of energy conversion, however, is still too low. Here the poor understanding of moving drops still hampers the development of useful hydrovoltaic generators.

In accepted studies in the literature, drop motion is determined by viscous dissipation due to hydrodynamic flow in the drop and by activated processes, in which the contact line has to overcome local energy barriers leading to contact-line friction  $^{6,16-22}$ . The viscous force of a sliding drop is commonly split in two components. Both are, to the first order, proportional to slide velocity U. One component comes from the viscous dissipation in the bulk,  $F_{\rm b}$ , and the other from the wedge of the drop,  $F_{\rm w}$  (refs.  $^{23-25}$ ). Viscous dissipation in the wedge and contact-line friction change the macroscopically observed advancing and receding contact angles, namely,  $\Theta_{\rm a}(U)$  and  $\Theta_{\rm r}(U)$ , respectively. As a result, the capillary force acting on a sliding drop  $^{4,26,27}$ 

$$F_{\rm c} = w\gamma k \left(\cos\Theta_{\rm r} - \cos\Theta_{\rm a}\right) \tag{1}$$

depends on the velocity. Here w is the width of the contact area of the drop,  $\gamma$  is the surface tension of the liquid and  $k \approx 1$  is a geometrical factor that depends on the detailed shape of the drop  $^{24,27-30}$ . Bulk viscous dissipation, which is much lower than viscous dissipation in the wedge, can be approximated by  $F_{\rm b} \approx \eta \frac{\pi \hbar w}{2H} U$  (Supplementary Section 1). Here  $\eta$  denotes the dynamic viscosity of the liquid, l is the length of the drop and H is its height.

Here by a simple tilted-plate experiment, we demonstrate that the motion of drops cannot be accurately predicted by these forces. In a tilted-plate experiment, a defined gravitational force  $F_{\rm g} = m {\rm gsin} \alpha$  is acting in the lateral direction<sup>21,25,31–36</sup>. Here m is the mass of the drop,  $g = 9.81 \, {\rm m \, s^{-2}}$  is the standard acceleration of gravity and  $\alpha$  is the tilt angle.

Two observations demonstrate that the trajectories of the sliding drops require more than hydrodynamics and activated processes. First, on surfaces with identical surface chemistry but different substrate conductivities and substrate thicknesses, we see different average velocities. For example, in Fig. 1a-d, we show surfaces coated with perfluorooctadecyltrichlorosilane (PFOTS): a silicon wafer with ~2 nm oxide layer, a 1-mm-thick SiO<sub>2</sub> plate and a 5-mm-thick SiO<sub>2</sub> plate. The first drop on each surface had an average velocity of  $0.25 \,\mathrm{m \, s^{-1}}$  (Fig. 1a),  $0.18 \,\mathrm{m \, s^{-1}}$  (Fig. 1b) and  $0.06 \,\mathrm{m \, s^{-1}}$ (Fig. 1c), respectively. When substrate conductivity was higher than that in the wafer, we observed even faster drop motion. Gold surfaces coated with a monolayer of perfluorodecanethiol (Fig. 1e) and Teflon (Fig. 1f) films have surface chemistry comparable to PFOTS, yet with average velocities of 0.42 and 0.48 m s<sup>-1</sup>, respectively. Water drops move faster on these surfaces than on PFOTS-coated SiO<sub>2</sub> surfaces. This simple experiment alone demonstrates that there is an important contribution missing in the description of drop motion.

Our second piece of evidence is that for a series of drops, sliding speeds become dependent on the drop number and thus dependent

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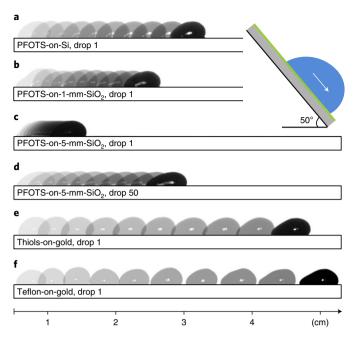


Fig. 1 | Movement of drops on different surfaces. Water drops  $(33 \,\mu)$  sliding down a plate tilted by 50° after detaching from a grounded electrode and imaged every 10 ms with a side-view camera.

on surface history. For example, the drop 50 sliding down a PFOTS-on-5-mm-SiO $_2$  plate is faster than the drop 1 (Fig. 1d). The surface chemistries of the three samples mentioned are identical and thus one expects identical capillary and viscous forces; however, the sliding speed of the drops varied by more than a factor of two, both between samples and between successive drops.

We believe that one logical explanation for this missing force is electrostatics. It is known that on bulk Teflon samples, fluorinated insulators and superhydrophobic surfaces, sliding water drops deposit negative electric charges, whereas the drops acquire a positive charge<sup>8,9,11,37-42</sup>. It is commonly believed that the surface charges behind sliding water drops are remnants of interfacial charges generated spontaneously at the water–solid interface<sup>8,11,37,43,44</sup>. Hydrophobic surfaces usually charge negatively in water. The reason for this charge is still debated<sup>45</sup>. The most popular explanation is an enrichment of hydroxyl ions at the interface. Alternative hypotheses speculate the origin of interfacial charge in the asymmetry of the hydrogen-bond network<sup>46</sup>, adsorption of bicarbonate/carbonate ions<sup>47</sup> or the flow of electrons from water to the polymer<sup>15</sup>.

Surface charges generate an electric field in the air above the surface. A charge q on top of an infinitely extending dielectric half-space with a relative permittivity  $\varepsilon_{\rm S}$  generates an electric field

$$E = \frac{q}{2\pi\varepsilon_0 \left(\varepsilon_S + 1\right) r^2}.$$
 (2)

Here,  $\varepsilon_0$  is the vacuum permittivity and r is the distance from the charge. If we now place a charged drop atop this charged surface, the drop will experience a Coulomb force that scales with  $1/(1 + \varepsilon_s)$ .

Given the importance of moving drops in our daily lives, we will address the following questions: is it possible to quantitatively measure electrostatic forces on moving drops? How? Can electrostatic forces explain the measured drop trajectories? Specifically, why and how does the substrate influence drop motion? Why is the motion of a drop influenced by previous drops? To answer these questions and to directly measure the forces acting on moving drops,

we developed a new method to analyse tilted-plate experiments (Fig. 2a and Supplementary Section 2).

We prepared smooth, hydrophobic surfaces with receding and advancing contact angles ranging within 77-110° and 93-122°, respectively (Fig. 2b and Supplementary Section 3). All the surfaces had a root-mean-squared roughness of ≤1 nm, as determined by scanning force microscopy (SFM; Supplementary Section 4). To find out how strong the electrostatic forces are, we varied the substrate and its thickness d with respect to a grounded metal back-electrode. We chose  $SiO_2$  plates ( $\varepsilon_S = 3.7$ ; Supplementary Section 5) as a low-permittivity substrate and Si wafers with only a natural oxide layer as a high-permittivity sample ( $\varepsilon_s = 11.7$ ; data from the supplier, Silicon Materials). The stability of the coatings was confirmed by measuring the drop velocity, advancing and receding contact angles, and morphology before and after 1,000 water drops sliding down the reference surfaces. None of the parameters had changed (Supplementary Section 6). In the presence of the grounded metal back-electrode, the field is screened by image charges. The distance to the grounded metal layer defines the screening length.

To describe the results and analysis, we first concentrate on PFOTS-coated samples (Fig. 3a and Supplementary Section 7). For the PFOTS-on-Si sample, the first, second and subsequent drops showed similar velocity profiles (Fig. 3a, green symbols). In contrast to common expectation, on 1-mm- and 5-mm-thick SiO<sub>2</sub> substrates (Fig. 3a, blue and red symbols), the velocity profiles of the first, second and subsequent drops were distinctly different, although all the samples have similar contact angles. First, the velocities tended to be lower on SiO<sub>2</sub> than the silicon wafer. Second, often, rather complex traces occurred. Although complex, these traces are systematic and reproducible. For example, on the PFOTS-on-5-mm-SiO<sub>2</sub> sample, the first drop shows a monotonically increasing velocity (Fig. 3a, red squares). However, for drop number 100 (Fig. 3a, red stars), the velocity increased for the first 3 cm, but then decreased again.

We draw two conclusions. First, the drop motion is not simply determined by viscous dissipation and activated dynamics at the contact line. Second, there is a fundamental difference between static and dynamic wetting. The static shape of a drop is largely determined by the properties of the top-most 1 nm of the surface; the substrate underneath has little influence (except in the case of strong externally applied electric fields such as in electrowetting<sup>48</sup>). In contrast, the dynamic properties such as the sliding speed are influenced by the substrate down to a thickness of the order of 1 mm.

To quantify the extra force, we analyse the equation of the motion of a drop:

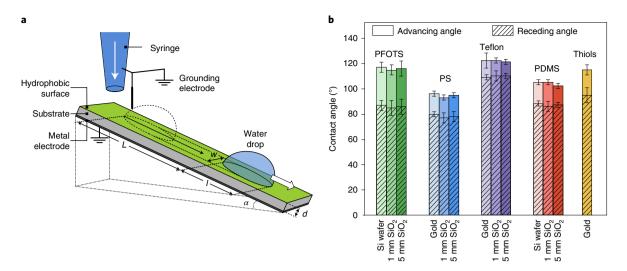
$$m^* \frac{\mathrm{d}U}{\mathrm{d}t} = mg \sin \alpha - F_{\mathrm{r}}(U) - F_{\mathrm{e}}^n(U, L). \tag{3}$$

In the acceleration term  $(m^* \frac{\mathrm{d}U}{\mathrm{d}t})$ , we take into account the rolling components in drop motion  $^{6,16,21,36,49,50}$ . Therefore, we used the effective mass  $m^*$ , which was determined by the direct numerical diffuse-interface simulations of the flow pattern inside sliding drops (Supplementary Section 8). These simulations gave an estimate of  $m^*/m = 1.05$  as a good mean value for the velocity range covered by our experiments.

All the forces acting on the drop in the absence of electrostatic effects are summarized in the reference force,  $F_{\rm r}(U)$ . The reference force depends on the velocity U but not on the slide length L, because the surfaces are homogeneous. For the extra force  $F_{\rm e}$ , the subscript 'e' indicates 'extra' or presumably 'electrostatic'. It may depend on the velocity, slide length and drop number n.

To obtain the reference force, we assume that on Si wafers, electrostatic forces are negligible. This assumption is in line with the fact that no differences in velocity were observed between successive

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**Fig. 2 | Experimental design. a**, Schematic of the experimental setup (Supplementary Section 2). **b**, Hydrophobic samples under investigation. The 'static' advancing and receding contact angles  $\Theta^0_a$  and  $\Theta^0_r$  were measured with sessile water drops as they slowly inflated and deflated, and imaged in the side view (Supplementary Section 3). The errors arise due to repeated measurements on different positions and samples.

drops (Fig. 3a). With equation (3), we obtain  $F_r = mg \sin \alpha - m^* \frac{\mathrm{d} U}{\mathrm{d} r}$ . The acceleration is obtained from the measured velocity traces, U(t). The reference forces increase linearly in the velocity range up to  $0.4\,\mathrm{m\,s^{-1}}$  (Fig. 3b). This increase is correlated with an increase in length and decrease in width of the drops (Supplementary Section 9).

By inserting the respective drop widths as well as the advancing and receding contact angles into equation (1), we calculated the capillary force with k=1 (Supplementary Fig. 9, red symbols). The capillary forces, which include wedge viscous forces (Supplementary Section 1), make up for most of the measured reference forces (Supplementary Fig. 9, black symbols). The bulk viscous forces (Supplementary Fig. 9, blue symbols) contribute less than 10% to the reference force (Supplementary Section 10).

With the reference force  $F_r(U)$  obtained from the experiments on Si wafers, we use U(t) curves measured on SiO<sub>2</sub> to calculate the extra force using equation (3) as  $F_e^n = mg \sin \alpha - m^* \frac{\mathrm{d}U}{\mathrm{d}t} - F_r$  (Fig. 3c and Supplementary Section 11). These extra forces are substantial, they depend on the drop number, n and they show complex distance dependency. Usually, the first and second drops experienced a strong force of  $60-100\,\mu\mathrm{N}$  (up to 50% of the reference force), which then decayed over the observation range of 4cm. The force is positive, hindering the drop motion. After around five drops, the initially high, decaying force gradually changed to an initially low, increasing extra force. Drop 100 showed almost an inverted profile of drop 1: starting at around  $30\,\mu\mathrm{N}$ , it typically increased to  $60\,\mu\mathrm{N}$  after 4cm slide length.

To determine the origin of the extra force, we measured the drop charges (Supplementary Section 12). In agreement with earlier results  $^{39}$ , on  $\mathrm{SiO}_2$  substrates, the drops gained a positive charge and left behind a negative surface charge. For the first drop, the charge was typically  $Q_1 = 1.0 - 1.5\,\mathrm{nC}$  on 1 mm and 5 mm  $\mathrm{SiO}_2$  (Fig. 3d and Supplementary Table 2). It decreased with subsequent drops until it reached a saturation value of the order of 0.4 nC. In contrast, on silicon wafers, the drop charges were typically 5–10 times lower. We used these values of drop charges to model the electrostatic force.

Modelling the electrostatic force allowed us to explain the shapes and magnitudes of the measured extra force. We derive the electric field by integrating the field strength (equation (2)) for the surface charge density  $\sigma_n(x)$ . We then multiply it with the drop charge  $Q_n(x)$  to obtain the electrostatic force of the nth of drop:

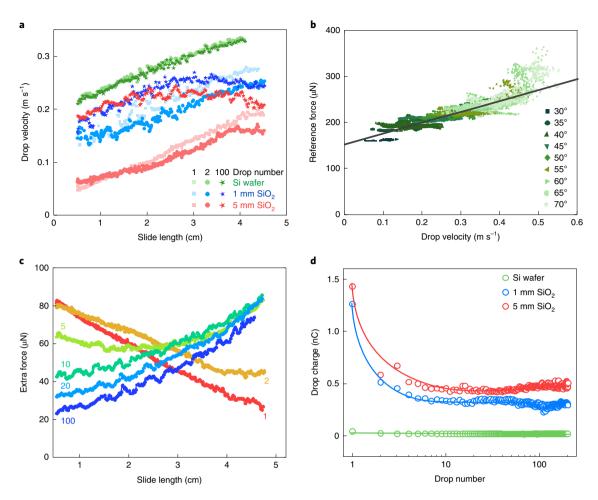
$$F_{e}^{n}(L) = -\frac{wQ_{n}(L)}{2\pi\varepsilon_{0}(\varepsilon_{S}+1)}$$

$$\left(\int_{0}^{L} \frac{\sigma_{n}(x)}{(L+a-x)^{2}} dx - \int_{L+1}^{L_{end}} \frac{\sigma_{n-1}(x)}{(x-L-a)^{2}} dx\right). \tag{4}$$

Here, *x* is a coordinate along the path of the drop itself and the path of previous drops. The first integral represents the interaction of the drop with surface charges behind the drop. The second integral represents the interaction with charges deposited by previous drops ahead of the current drop (Supplementary Section 13). The parameter *a* characterizes the centre position of the charge of the drop; it is the horizontal distance to the rear rim (Supplementary Section 13 and Supplementary Fig. 13). Its value was obtained from numerical calculations of the electric-field distribution and electrostatic force (Supplementary Section 13).

We use a previously derived model to obtain plausible expressions for  $\sigma_n(x)$  and  $Q_n(x)$  (ref. <sup>39</sup>). Briefly, surface charges behind a sliding drop are the remnants of interfacial charges spontaneously generated at the water-solid interface8,11,37,43 (Fig. 4a). Hydrophobic surfaces usually charge negatively in water, probably by the adsorption of hydroxyl ions. Some of these charges fail to neutralize at the rear of the sliding drop and remain on the surface. As a result, the drop becomes positively charged. However, the transfer of charges to the solid-air surface decreases with an increasing drop potential<sup>39</sup>. As a result, the density of the deposited surface charges decreases with distance:  $\sigma_1 = \sigma_0 e^{-x/\lambda}$ . Here  $\sigma_0$  is the initial surface charge density and  $\lambda$  is the decay length (Supplementary Section 14). In addition, we allow the neutralization of surface charges with time. It is not yet clear which processes dominate surface neutralization, for example, flow of electrons through the grounded substrate or via the surface, ions in the air, or the ejection of electrons<sup>8,42</sup>. Neutralization is characterized by an exponential process with a relaxation time constant  $\tau$  of typically 10 s. Based on the independent parameters  $\sigma_0$ ,  $\lambda$  and  $\tau$  (Supplementary Section 12 and Supplementary Table 2), the surface charge density can be written as a function of the position and drop number.

Using equation (4), we obtain an analytical expression for the electrostatic force on the first drop (equation (14) in the Supplementary Information) and for higher drop numbers ( $n \rightarrow \infty$ ; equation (21) in the Supplementary Information). The calculated electrostatic force yields the same order of magnitude as the experimental results (Fig. 4b), and it explains the observed flip in



**Fig. 3** | Results obtained with 33 μl water drops on PFOTS-coated samples. **a**, Velocity versus slide length for PFOTS-on-Si (green symbols), 1 mm SiO<sub>2</sub> (blue) and 5 mm SiO<sub>2</sub> (red) sliding down at an inclination of  $\alpha = 50^{\circ}$ . Supplementary Section 7 provides data for other tilt angles. **b**, Reference forces measured on four PFOTS-on-Si samples. Fitting the results for  $U \le 0.4$  m s<sup>-1</sup> (grey lines) led to  $F_r = 156$  μN + (218 μN s m<sup>-1</sup>)U. **c**, Extra forces acting on the 1st, 2nd, 5th, 10th, 20th and 100th drop sliding down 50°-tilted PFOTS-on-5-mm-SiO<sub>2</sub> sample at 1.3 s intervals. Intervals greater than 1s were chosen to ensure that an adsorbed water film or nanodroplets behind a drop had time to equilibrate with the vapour phase. Forces were calculated with equation (3) with the PFOTS-on-Si sample as the reference. **d**, Measured drop charge versus drop number on PFOTS-coated samples. The results were measured at 50° tilt, 1.5 s intervals between the deionized water drops of 45 μl volume after 4 cm slide length. The lines are guides for the eye. Supplementary Section 12 provides additional details.

the slope of  $F_e$  versus L curves when going from the first to subsequent drops with  $n \ge 10$ .

All the drops start with zero charge and thus zero electrostatic force. The first drop deposits a negative charge on the neutral surface and acquires a positive charge within a distance of  $L\approx\lambda$  (Fig. 4b, top-left schematic). The increase in drop and surface charges leads to a steep increase in the retarding electrostatic force, with a peak at  $L\approx0.8\lambda$ . As a result of drop charging, the drop potential increases, which hinders further charge deposition, and the drop charge saturates. As the drop reaches saturation and moves further from the strongly charged region of the surface, the retarding electrostatic force decreases (Fig. 4b, bottom-right schematic).

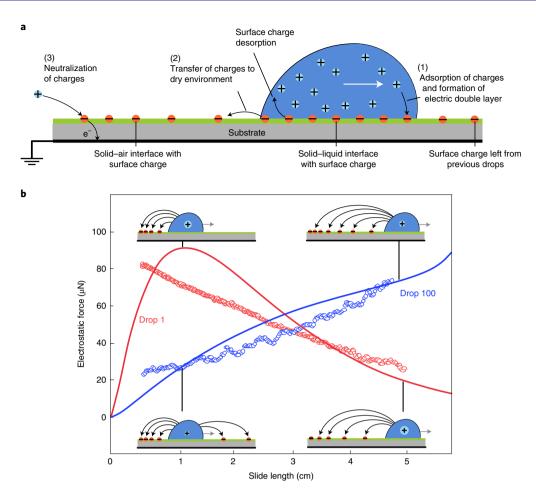
The maximum value predicted by the analytical solution at the beginning was missing in the experiments (Fig. 4b, red symbols). This could be the effect of an additional negative surface charge deposited right after the drop impacts the surface before touching the first grounded electrode. As a result, the maximum value would be outside our observation range. It was observed on other substrates described below.

For higher drop numbers (Fig. 4b, blue line, and Supplementary Fig. 15), the electrostatic retardation increases with slide distance because of two effects. First, the surface charge density is already

high from previous drops. As a result, the drop needs to cover a larger distance to reach its saturation charge (Fig. 4b, top-right schematic). Thus, the increase in force (for the first drop, it happens in the first 1 cm) is stretched to a distance of  $\geq$ 4 cm. Second, the surface charges in front of the drop that are left behind by previous drops lead to an acceleration. At the end of the path, the electrostatic force increases even more steeply because there are no more attractive charges ahead since the sample ends.

The good agreement between experiment and electrostatic theory indicates that on PFOTS-coated insulators, the extra forces are predominantly caused by electrostatic charging. To find out how ubiquitous electrostatic forces are, we performed experiments on other hydrophobic samples. When using conductive substrates or high-permittivity substrates (polystyrene (PS)-on-gold, Teflon-on-gold, polydimethylsiloxane (PDMS)-on-Si and thiols-on-gold substrates), the first, second and subsequent drops showed similar velocity profiles (Supplementary Section 15 and Supplementary Fig. 18). Thus, electrostatic effects are negligible. In contrast, on 1-mm- and 5-mm-thick SiO<sub>2</sub> coated with PS, Teflon or PDMS, the velocity profiles of the first, second and subsequent drops were distinctly different (Supplementary Section 15 and Supplementary Fig. 19). This observation indicates that drop

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**Fig. 4 | Comparison between experimental results and the theoretical model. a**, Model applied to calculate the electrostatic forces versus slide length for a series of drops. Step (1): surface charges are generated when water comes into contact with the surface at the front of the drop, for example, by the adsorption of OH<sup>-</sup>, leaving H<sub>3</sub>O<sup>+</sup> in the solution. Step (2): at the rear side of the drop, most surface charges are neutralized, for example, by the desorption of OH<sup>-</sup>. A fraction of the surface charges, however, transfers to the solid-air interface. Step (3): charges are neutralized. **b**, Calculated electrostatic force acting on the first drop (red line; equation (14) in the Supplementary Information) and after a large number of drops (blue line; equation (21) in the Supplementary Information). For comparison, we plotted the experimental results (symbols) for the 1st and 100th drop sliding down the PFOTS-on-5-mm-SiO<sub>2</sub> sample (Fig. 3c). The parameters were chosen as determined from the measurements of drop charges (Supplementary Table 2;  $σ_0 = 2 \times 10^{-5} \,\mu\text{C}$  m<sup>-2</sup>,  $λ = 1.5 \,\text{cm}$ ,  $τ = 7 \,\text{s}$ ), the experimental conditions ( $w = 4 \,\text{mm}$ ,  $l = 5 \,\text{mm}$ ,  $Δt = 1.3 \,\text{s}$ ,  $L_{\text{end}} = 6 \,\text{cm}$ ), and the numerical computations for 5-mm-thick substrates ( $a = 1 \,\text{mm} = 0.2l$ : Supplementary Section 14).

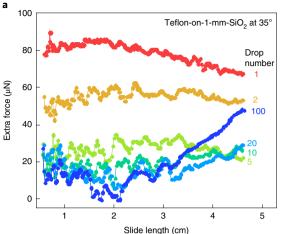
motion is substantially influenced by electrostatic forces. The charging of drops was detected on all the hydrophobic surfaces on  ${\rm SiO_2}$  (Supplementary Section 12 and Supplementary Fig. 12). In contrast, for the PS-on-gold, Teflon-on-gold and PDMS-on-Si samples, charging was at least ten times lower.

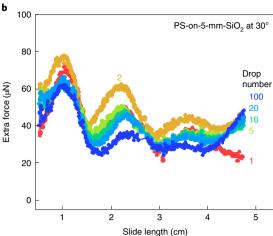
A complex variety of  $F_e^n$  versus L graphs were observed, depending on the drop number, tilt angle and substrate thickness. Two typical examples are plotted in Fig. 5; a full set of results is shown in Supplementary Sections 16 and 17. On several samples, such as the Teflon-on-1-mm-SiO<sub>2</sub> sample, we observed the maximum in the force versus slide length curves predicted by the electrostatic theory for the first drop (Fig. 5a). We assume that a slight increase in decay length  $(\lambda)$  shifts the maximum value into our observation window. The charge measurements confirmed that indeed on Teflon,  $\lambda$ =2.5 cm (compared with  $\lambda$ =1.5 cm on PFOTS; Supplementary Table 2). For higher drop numbers, the maximum value became weaker and for drop numbers  $n \ge 10$ , an increasing extra force started to dominate at larger slide lengths, in agreement with equation (21) in the Supplementary Information.

Figure 5a, however, also shows the limits of the simple model. It does not predict the minimum value in the electrostatic force

for  $n \ge 10$  at shorter slide lengths. This deficit could be related to the assumption that charge deposition is independent of the slide velocity. Since the deposition of charges is a non-equilibrium process, it most likely depends on the velocity. At a low velocity, charge deposition is probably less pronounced than assumed. A velocity dependence of charge deposition is most likely also the reason for the oscillating electrostatic forces observed, for example, on the PS-on-5-mm-SiO<sub>2</sub> sample (Fig. 5b). The oscillation period was not related to drop vibrations, which were at 50 Hz or faster. Thus, a future refinement of the description of charge deposition needs to include the velocity of the receding contact line.

Electrostatic retardation is not restricted to pure water. In aqueous drops containing 0.1–1,000.0 mM NaCl, electrostatic forces made up to 50% of the total force when sliding down the PFOTS-on-1-mm-SiO<sub>2</sub> sample (Supplementary Section 18 and Supplementary Fig. 24). For drops of ethylene glycol ( $\varepsilon_{\rm S}$ = 37,  $\gamma$ =0.048 N m<sup>-1</sup>,  $\eta$ =0.016 Pa s, V=18.6 µl) on the Teflon-on-1-mm-SiO<sub>2</sub> sample, the electrostatic forces for the first and second drops were of the order of 100 µN; they were even stronger than those for water despite the high viscosity and slow motion of drops (Supplementary Section 18 and Supplementary Fig. 25).





**Fig. 5 | Examples of extra forces acting on water drops sliding down. a**, Teflon-on-1-mm-SiO<sub>2</sub> sample at 35° tilt. **b**, PS-on-5-mm-SiO<sub>2</sub> sample at 30° tilt. The results are plotted for the 1st, 2nd, 5th, 10th, 20th and 100th drop. Extra forces were calculated with equation (3), and  $F_r = 48 \,\mu\text{N} + (175 \,\mu\text{N} \,\text{s} \,\text{m}^{-1})U$  obtained with the Teflon-on-gold sample and  $F_r = 74 \,\mu\text{N} + (398 \,\mu\text{N} \,\text{s} \,\text{m}^{-1})U$  measured on the PS-on-gold sample as reference forces (Supplementary Fig. 20).

One additional consequence of electrostatic retardation is that impacting drops rebound differently depending on the conductivity and permittivity of the substrates. For example,  $20\,\mu$ l water drops falling from a height of  $2.5\,\mathrm{cm}$  fully rebound from the Teflon-on-gold substrate. In contrast, the same drops stick on the Teflon-on-SiO<sub>2</sub> substrate (Supplementary Section 19). When tilting the surface by  $10^\circ$ , drops rebound on the Teflon-on-gold substrate and roll off completely. On SiO<sub>2</sub>, drops do not rebound but split apart and stick to the surface. In particular, in printing and coating applications, for the production of window screens and glasses or in heat exchangers, this variation in electrostatic force may control whether impacting drops rebound from or stick to a surface. In general, the insight that surface permittivity influences drop motion opens new avenues towards engineering surfaces with desired wetting properties.

# Online content

Any methods, additional references, Nature Research reporting summaries, source data, extended data, supplementary information, acknowledgements, peer review information; details of author contributions and competing interests; and statements of data and code availability are available at https://doi.org/10.1038/s41567-022-01563-6.

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#### Methods

Tilted-plate experiments. To measure the forces acting on sliding drops, 33 µl drops of distilled water (<1 µS cm<sup>-1</sup>; Gibco, Thermo Fisher Scientific), 1 M NaCl solution (Carl Roth), 0.1 mM NaCl solution (made from 10 µl M NaCl solution and 100 ml distilled water) and ethylene glycol (99.8%; Sigma-Aldrich) were deposited at intervals of 1.3 s at the top of a tilted sample by a grounded syringe needle (1.5 mm outer diameter, Dosiernadel Vollmetal), which was connected to a peristaltic pump (MINIPULS 3, Gilson) (Supplementary Fig. 1). Before every series of drops, the surfaces were neutralized by an ionizing air blower for 10 min (Aerostat PC ionizing air blower, Simco-Ion). The drops fell ~5 mm, just enough so that they detached from the syringe before touching the surface. To make sure the drops start sliding without any initial charge, they were neutralized by a 0.025-mm-diameter grounded tungsten wire, right after they landed on the surface. The position where the drops detach from the grounded wire corresponds to the zero slide length (L=0). The observation range starts where the full drop has detached from the grounded wire and the wire is not in the image anymore, that is, at L = 0.5 cm. Then, we imaged the drop with a frame rate of 1,000 frames per second in the side and front views over a length of typically 4.5 cm with a high-speed camera (FASTCAM Mini UX100 (Photron) with a TitanTL telecentric lens, ×0.268, one inch, C-mount (Edmund Optics)). By applying two parallel mirrors (25 × 36 mm<sup>2</sup> protected silver mirror; PFR10-P01, Thorlabs) on both sides of the sample to guide the backlight from the telecentric backlight illuminator (138 mm; Edmund Optics), we also imaged the front view of the sliding drops at the same time. After typically  $L_{\rm end}$  = 6 cm, the rim of the sample was reached and the drops fell off. To access a wide velocity range, we varied the tilt angle (Supplementary Fig. 6a). On longer samples, we verified that after a slide length of ~10-15 cm, the drops reach a steady-state velocity (Supplementary Fig. 6b). From video images, we extract slide length L, drop velocity U, contact angles at the front (advancing contact angle,  $\Theta_a$ ) and rear (receding contact angle,  $\Theta_r$ ), and length and width of the drop. All the parameters vary with time and thus with position. To extract  $\Theta_a(U)$  and  $\Theta_r(U)$  from the videos, we adapted the open drop-shape analysis from MATLAB (DSAfM) version 9.5.0.944444 (R2018b). The dynamic contact angles were determined by applying a polynomial fit to every contour image (Supplementary Section 2). All the measurements were conducted at a temperature of  $20 \pm 1$  °C and a humidity of 15-30%.

Sample preparation. Five types of surface were prepared. (1) PFOTS monolayers on Si wafer, 1-mm-thick and 5-mm-thick SiO<sub>2</sub> slides were prepared by chemical vapour deposition. After O<sub>2</sub>-plasma cleaning at 300 W for 10 min (Femto low-pressure plasma system, Diener electronic), the Si wafer (native oxide layer of  $1.6 \pm 0.3$  nm as measured by ellipsometry; resistivity,  $< 0.005 \Omega$  cm; thickness,  $525 \pm 25 \mu$ m; Silicon Materials) and the SiO<sub>2</sub> slides were placed in a vacuum desiccator containing a vial with 0.5 ml 1H,1H,2H, 2H-perfluorooctadecyltrichlorosilane (97%; Sigma-Aldrich). We used 1-mm-thick SiO<sub>2</sub> slides (76.2×25.4×1.0 mm<sup>3</sup>; Thermo Fisher Scientific) and 5-mm-thick SiO<sub>2</sub> slides (75.0×25.0×5.0 mm<sup>3</sup>; Präzisions Glas & Optik). The desiccator was evacuated to less than 100 mbar, closed, and the reaction was allowed to proceed for 30 min. Before measurement, the PFOTS surfaces were rinsed with ethanol to remove any unbound silanes. (2) PS films on gold, 1-mm-thick and 5-mm-thick SiO<sub>2</sub> slides were prepared by dip coating. To get gold substrates, 30 nm gold was sputtered onto 75×25 mm<sup>2</sup> glass slides that had been precoated with 5 nm chromium to improve adhesion. The solution consisted of 1 wt% PS (molecular weight,  $192 \text{ kg mol}^{-1}$ ,  $\varepsilon = 2.6$ ; Sigma-Aldrich) in toluene. After moving down the substrates at a speed of 90 mm min-1 into the solution and waiting for 10 s, the substrates were moved up again at a speed of 90 mm min<sup>-1</sup>. Finally, the films were annealed in an oven at 120 °C under a vacuum for 24 h. The PS films were 20 nm thick measured by a profiler (P-7 stylus profiler, KLA-Tencor). (3) Teflon AF1600 (Teflon) films on gold, 1-mm-thick and 5-mm-thick SiO2 slides were prepared by dip coating. Sputter-coated gold glass slides (see above) or SiO<sub>2</sub> slides were immersed into 1 wt% Teflon AF1600 ( $\varepsilon$  = 1.9; Sigma-Aldrich) in FC-43 (Sigma-Aldrich) at a speed of 90 mm min-1. After being immersed for 10 s, the substrates were withdrawn from the solution at a constant speed of 10 mm min<sup>-1</sup>. Finally, the films on the substrates were annealed at 160 °C in a vacuum for 24h. Teflon AF1600 films were 60 nm thick to avoid dewetting. We determined that the roughness increased with an increase in film thickness (Supplementary Section 20). (4) PDMS polymer brushes on Si wafers, 1-mm-thick and 5-mm-thick SiO<sub>2</sub> slides were prepared as described elsewhere<sup>51</sup>. After O<sub>2</sub>-plasma cleaning (see above), few PDMS drops (molecular weight, 6 kg mol-1; Alfa Aesar) were deposited on a Si wafer or SiO<sub>2</sub>. After the PDMS drop spread and covered the substrates, the samples were kept at 22–23  $^{\circ}\text{C}$  and 30–60% relative humidity for 24-48 h. Then, they were rinsed with toluene and sonicated in toluene, ethanol and deionized water for 10 min each to wash away any unbound PDMS. The brushes

were ~3 nm thick¹. (5) 1H,1H,2H,2H-perfluorodecanethiol (thiols) monolayers on gold: directly after the preparation of the gold-coated glass slide (see above), the surfaces were immersed in a 1 mM ethanolic thiol (≥96.0%; Sigma-Aldrich) solution for 24h. Then, the surfaces were rinsed by pure ethanol and dried by Ar, blowing.

SFM imaging. All the hydrophobic surfaces were studied using SFM (Dimension Icon, Bruker) in the tapping mode (Supplementary Fig. 2). The SFM tips with a nominal resonance frequency of 300 kHz and spring constant of 26 N m $^{-1}$  were used (160AC-NA, OPUS). The root-mean-squared roughness was determined on the areas of  $0.5\times0.5\,\mu\text{m}^2$  for each sample. The error was around 0.1 nm, except for the thiols-on-gold and PFOTS samples, where it was 0.2 nm. The errors were determined from variations observed at different positions on the samples and variations in the different samples.

Static contact angle measurements. 'Static' advancing and receding contact angles, namely,  $\Theta_a^0$  and  $\Theta_r^0$ , respectively, were measured with sessile water drops (OCA 35, DataPhysics Instruments). An 8  $\mu$ l water drop was deposited on the surface. Then, 16  $\mu$ l deionized water was pumped into the drop and subsequently sucked out at the rate of  $0.5\,\mu$ l s $^{-1}$  by a Hamilton syringe connected to a hydrophobic needle. The process was repeated three times without interruption. During inflation and deflation, the drops were imaged in the side view. Then,  $\Theta_a^0$  and  $\Theta_r^0$  were calculated by fitting an ellipse model to the contour images.

## Data availability

Source data are provided with this paper. All other data that support the plots within this paper and other findings of this study are available from the corresponding authors upon reasonable request.

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### **Author contributions**

X.L. prepared the samples, performed the tilted-plate experiments and analysed the data. X.L., A.S. and R.B. designed the tilted-plate setup. P.B., A.Z.S. and S.A.L.W. measured the drop charges. H.B. and S.A.L.W. numerically calculated the electrostatic force on a drop. F.B. and H.M. carried out the numerical diffuse-interface simulations of drop motion. S.A.L.W., S.H., M.T.S. and H.-J.B. derived the analytical theory. H.-J.B. derived the concept of extracting the electrostatic force from the equation of motion. All the authors discussed and interpreted the results and wrote the manuscript.

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#### **Competing interests**

The authors declare no competing interests.

# **Additional information**

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